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|-------------------------------------|----------------------------------|--------------------------|-------------------------------|
| AMENDMENT TRANSMITTAL LETTER | | | Docket No. H6808.0041/P041 |
| Application No. 10/780,752 | Filing Date February 19, 2004 | Examiner G. M. Desire | Art Unit 2625 |

Applicant(s): Michio Nakano et al.

Invention: IMAGE PROCESSING UNIT FOR WAFER INSPECTION TOOL

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

| CLAIMS AS AMENDED | | | | | |
|--|---|---|-----------------------------------|------|----------|
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | |
| Total Claims | 8 | - 20 = | | x | |
| Independent Claims | 2 | - 6 = | | x | |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | |
| Other fee (please specify): Extension for response within third month | | | | | 1,050.00 |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 1,050.00 |

- ☒ Large Entity ☐ Small Entity
- ☐ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. 04-1073 in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.
- ☒ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 04-1073
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

[Handwritten signature] #41,178

Mark J. Thronson
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Dated: January 11, 2008

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Docket No.: H6808.0041/P041
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Michio Nakano et al.

Application No.: 10/780,752

Confirmation No.: 1776

Filed: February 19, 2004

Art Unit: 2625

For: IMAGE PROCESSING UNIT FOR WAFER
INSPECTION TOOL

Examiner: G. M. Desire

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 13, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.